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July 27, 2005

Commissioner for Patents P.O. Box 1450 Alexandria, Virginia 22313-1450

Re:

Patent Application for Kazutaka Shibata

Application No. 10/727,577

Dear Sir:

We are returning herewith an Office Action mailed in above-identified application that was erroneously mailed to our firm on July 7, 2005. We are not the responsible attorneys of record for this matter.

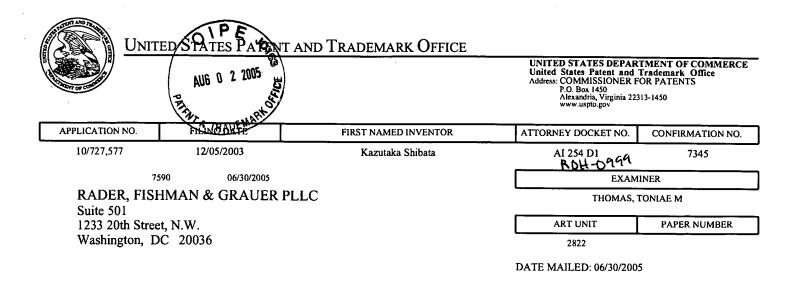
Very truly yours,

RADER, FISHMAN & GRAUER PLLC

Kalarek

Paula L. Talarek Office Manager

PLT/ Encl.



Please find below and/or attached an Office communication concerning this application or proceeding.

OIPE	w .		,	
	Application	n No.	Applicant(s)	
AUG 0 2 7	005 E 10/727,57	7	SHIBATA, KAZU	TAKA
Office Action Summany	Examiner		Art Unit	
THE PROPERTY OF THATE			2822	
The MAILING DATE of this communication Period for Reply	appears on the	cover sheet with the d	correspondence a	ddress —
A SHORTENED STATUTORY PERIOD FOR RI THE MAILING DATE OF THIS COMMUNICATION Extensions of time may be available under the provisions of 37 CF after SIX (6) MONTHS from the mailing date of this communication If the period for reply specified above is less than thirty (30) days, If NO period for reply is specified above, the maximum statutory period for reply within the set or extended period for reply will, by a cannot be supply received by the Office later than three months after the rearmed patent term adjustment. See 37 CFR 1.704(b).	ON. FR 1.136(a). In no eve n. a reply within the statu eriod will apply and will statute, cause the appli	nt, however, may a reply be tin tory minimum of thirty (98) day expire SIX (6) MONTHS from exting to become ABADONE	nely filed s will be considered time the mailing date of this	ely. communication.
Status				
1)⊠ Responsive to communication(s) filed on <u>(</u>	05 December 20	03.		
	This action is no			
3) Since this application is in condition for all			secution as to th	e merits is
closed in accordance with the practice und				
Disposition of Claims				
4)⊠ Claim(s) <u>5-16</u> is/are pending in the applica	tion.			
4a) Of the above claim(s) is/are with		sideration.		
5) Claim(s) is/are allowed.				
6)⊠ Claim(s) <u>5-16</u> is/are rejected.				
7) Claim(s) is/are objected to.				
8) Claim(s) are subject to restriction a	nd/or election re	quirement.		
Application Papers				
9)☐ The specification is objected to by the Exar	miner.			
10)⊠ The drawing(s) filed on <u>12/05/03</u> is/are: a)[$oxtimes$ accepted or $\mathfrak k$	o)□ objected to by th	e Examiner.	
Applicant may not request that any objection to	the drawing(s) be	held in abeyance. See	e 37 CFR 1.85(a).	
Replacement drawing sheet(s) including the co				
11)☐ The oath or declaration is objected to by the	e Examiner. Not	e the attached Office	Action or form P	TO-152.
Priority under 35 U.S.C. § 119				
12)⊠ Acknowledgment is made of a claim for fore a)⊠ All b)□ Some * c)□ None of:	eign priority und	er 35 U.S.C. § 119(a)	-(d) or (f).	
1. ☐ Certified copies of the priority docum	ante have hace	rocoived		
2. Certified copies of the priority docum			an Na	
3. Copies of the certified copies of the				Stone
application from the International Bu			u III ulis Nauonai	Stage
* See the attached detailed Office action for a	-	` ''	d	
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Attachment(s)		. 🗂		
 Notice of References Cited (PTO-892) Notice of Draftsperson's Patent Drawing Review (PTO-948) 		4) Interview Summary Paper No(s)/Mail Da	(PTO-413) te.	
3) Information Disclosure Statement(s) (PTO-1449 or PTO/SE Paper No(s)/Mail Date	3/08)	5) Notice of Informal Pa 6) Other:	atent Application (PT	O-152)
J.S. Patent and Trademark Office PTOL-326 (Rev. 1-04) Office	e Action Summary	Par	t of Paper No./Mail D	ate 06272005

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DETAILED ACTION

1. This action is a first Office action on the merits of Application Serial No. 10/727,577, which is a divisional of Application Serial No. 10/284,318 filed 31 October 2002, now US Patent No. 6,867,501.

2. The preliminary amendment filed on 05 December 2003 canceled claims 1-4 and 17-18. Accordingly, claims 5-16 are currently pending.

Claim Rejections - 35 USC § 112

The following is a quotation of the second paragraph of 35 U.S.C. 112:

The specification shall conclude with one or more claims particularly pointing out and distinctly claiming the subject matter which the applicant regards as his invention.

3. Claims 9-14 are rejected under 35 U.S.C. 112, second paragraph, as being indefinite for failing to particularly point out and distinctly claim the subject matter which applicant regards as the invention.

The meaning of the claim language an insulator at between the first and second blocks as recited in claim 5 at line 5 is unclear. The phrase "at between" renders the claim indefinite. For purposes of examination, the language has been interpreted to mean an insulator between the first and second blocks.

The meaning of the claim language arranging a conductor therein onto <u>an</u> <u>one</u> surface as recited in claim 9 at lines 3-4 is unclear. The phrase "an one" renders the claim indefinite. For purposes of examination, the language has been interpreted to mean arranging a conductor therein onto one surface.

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The phrase the semiconductor chips as recited in claim 10 at line 3 lacks antecedent basis.

Claim Rejections - 35 USC § 102

The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

(e) the invention was described in (1) an application for patent, published under section 122(b), by another filed in the United States before the invention by the applicant for patent or (2) a patent granted on an application for patent by another filed in the United States before the invention by the applicant for patent, except that an international application filed under the treaty defined in section 351(a) shall have the effects for purposes of this subsection of an application filed in the United States only if the international application designated the United States and was published under Article 21(2) of such treaty in the English language.

4. Claims 9 and 13-16 are rejected under 35 U.S.C. 102(e) as being anticipated by Patti (US 6,642,081 B1).1

Patti discloses a method for manufacturing a semiconductor device (figs. 1-9 and accompanying text). The method includes: connecting face down a semiconductor chip 30 having an active surface formed with a recess arranging a conductor 52 therein onto one surface of a semiconductor substrate 20 (figs. 1, 8 and col. 6, lines 7-13); and polishing or abrading an inactive surface of the semiconductor chip 30 to expose the conductor 52 in the inactive surface of

¹ Applicant cannot rely upon the foreign priority papers to overcome this rejection because a translation of said papers has not been made of record in accordance with 37 CFR 1.55. See MPEP § 201.15.

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the semiconductor chip after the on-substrate connecting step (fig. 9 and col. 6, lines 28-31).

Another chip 40 is connected on to the semiconductor chip (fig. 1 and col. 3, lines 45-50).

The semiconductor chip 40 has an active surface formed with a recess arranging a conductor 53 therein, and is connected face down on to the semiconductor chip 30 (fig. 1). A polishing or abrading step is performed in an inactive surface of the semiconductor chip 40 to expose the conductor 53 in the inactive surface (fig. 1).

Likewise, Patti discloses a method for manufacturing a semiconductor device (figs. 1-9 and accompanying text), wherein the method includes: a step of connecting a semiconductor chip 20 on an active surface of a semiconductor substrate 30 having an active surface formed with a recess arranging a conductor 52 therein (figs. 1, 8 and col. 6, lines 7-13); and a step of polishing or abrading an inactive surface of the semiconductor substrate 30 to expose the conductor 52 (figs. 1, 9 and col. 6, lines 28-31).

Allowable Subject Matter

5. Claim 5 would be allowable if rewritten or amended to overcome the rejections under 35 U.S.C. 112, 2nd paragraph, set forth in this Office action. Claims 6-8 would be allowable if rewritten to overcome the rejection under 35 U.S.C. 112, 2nd paragraph, set forth in this Office action and to include all of the limitations of the base claim, claim 5, and any intervening claims. The

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prior art of record does not anticipate, teach or suggest a method for manufacturing a semiconductor device substantially, wherein the method comprises the combination of steps substantially as claimed.

6. Claims 10-13 would be allowable (1) if rewritten in independent form including all of the limitations of the base claim, claim 9, and any intervening claims; and (2) if rewritten to overcome the rejection(s) under 35 U.S.C. 112, 2nd paragraph, set forth in this Office action.

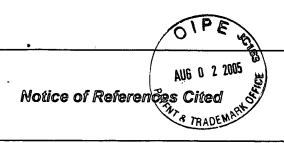
Any inquiry concerning this communication or earlier communications from the examiner should be directed to Toniae M. Thomas whose telephone number is (571) 272-1846. The examiner can normally be reached on Monday through Friday from 8:30 a.m. to 5:30 p.m.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Amir Zarabian can be reached on (571) 272-1852. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

TMT 27 June 2005

Mary Wilczewski Primary Examiner



	Application/Control No. 10/727,577	Applicant(s)/Patent Under Reexamination SHIBATA, KAZUTAKA		
ſ	Examiner	Art Unit		
	Toniae M. Thomas	2822	Page 1 of 1	

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-5,783,870	07-1998	Mostafazadeh et al.	257/791
	В	US-5,790,384	08-1998	Ahmad et al.	361/760
	C	US-5,825,080	10-1998	Imaoka et al.	257/659
	D	US-6,486,544	11-2002	Hashimoto, Nobuaki	257/686
	Е	US-6,498,053 B2	12-2002	Mastromatteo et al.	438/107
	F	US-6,633,081 B2	10-2003	Sahara et al.	257/738
	G	US-6,642,081 B1	11-2003	Patti, Robert	438/109
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	J	US-			
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FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

*	ļ	Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).) Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.